

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT												
NATURE OF CONVEYANCE:	ASSIGNMENT												
CONVEYING PARTY DATA													
<table border="1"><thead><tr><th>Name</th><th>Execution Date</th></tr></thead><tbody><tr><td>Kohei Kawamura</td><td>10/25/2004</td></tr><tr><td>Akira Asano</td><td>10/25/2004</td></tr><tr><td>Koutarou Miyatani</td><td>10/25/2004</td></tr><tr><td>Joseph T. Hillman</td><td>10/08/2004</td></tr><tr><td>Bentley Palmer</td><td>10/08/2004</td></tr></tbody></table>	Name	Execution Date	Kohei Kawamura	10/25/2004	Akira Asano	10/25/2004	Koutarou Miyatani	10/25/2004	Joseph T. Hillman	10/08/2004	Bentley Palmer	10/08/2004	
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<table border="1"><tr><td>Name:</td><td>Tokyo Electron Limited</td></tr><tr><td>Street Address:</td><td>3-6 Akasaka 5-Chome, Minato-Ku</td></tr><tr><td>Internal Address:</td><td>TBS Broadcast Center</td></tr><tr><td>City:</td><td>Tokyo</td></tr><tr><td>State/Country:</td><td>JAPAN</td></tr><tr><td>Postal Code:</td><td>107</td></tr></table>	Name:	Tokyo Electron Limited	Street Address:	3-6 Akasaka 5-Chome, Minato-Ku	Internal Address:	TBS Broadcast Center	City:	Tokyo	State/Country:	JAPAN	Postal Code:	107	
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PROPERTY NUMBERS Total: 1													
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CORRESPONDENCE DATA													
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Total Attachments: 6

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ASSIGNMENT OF INVENTION AND PATENTS THEREON

For valuable consideration, we, **Kohei Kawamura, Akira Asano, Koutarou Miyatani, Joseph T. Hillman, Bentley Palmer**, hereby assign to **Tokyo Electron Limited**, a Corporation of and having a place of business at **TBS Broadcast Center, 3-6 Akasaka 5-Chome, Minato-Ku, Tokyo 107 JAPAN**, and its successors and assigns (collectively hereinafter called "the Assignee"), our entire right, title and interest throughout the world in the inventions and improvements which are subject of an application for United States Patent filed **September 29, 2004** as application Serial No. **10/711,649**, entitled **A METHOD FOR SUPERCRITICAL CARBON DIOXIDE PROCESSING OF FLUORO-CARBON FILMS**, this assignment including said application, any continuation, division or continuation-in-part thereof and/or substitute therefor, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and authorize the Assignee to apply in all countries in our name or in its own name for patents, utility models, and design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements; and agree for ourselves and our respective heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this assignment.

Inventor's Signature Kohei Kawamura Date '04/10/25
Full Name: Kohei Kawamura
Residence: Yamanashi, Japan

Inventor's Signature Akira Asano Date '04/10/25
Full Name: Akira Asano
Residence: Yamanashi, Japan

Inventor's Signature Koutaro Miyatani Date '04/10/25
Full Name: Koutarou Miyatani
Residence: Yamanashi, Japan

Inventor's Signature _____ Date _____
Full Name: Joseph T. Hillman
Residence: Scottsdale, Arizona

Inventor's Signature _____ Date _____
Full Name: Bentley Palmer
Residence: Phoenix, Arizona

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Inventor's Signature _____ Date _____

Full Name: Kohei Kawamura

Residence: Yamanashi, Japan

Inventor's Signature _____ Date _____

Full Name: Akira Asano

Residence: Yamanashi, Japan

Inventor's Signature _____ Date _____

Full Name: Koutarou Miyatani

Residence: Yamanashi, Japan

Inventor's Signature Joseph T. Hillman Date 10-8-04

Full Name: Joseph T. Hillman

Residence: Scottsdale, Arizona

Inventor's Signature _____ Date _____

Full Name: Bentley Palmer

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Residence: Yamanashi, Japan

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Inventor's Signature  Date 10/08/2004

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